

**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Oh et al.

Group Art Unit: 1795

**Serial No.: 10/615,842**

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

\* \* \* \* \*

**CHANGE OF ADDRESS FORM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please direct all future communications in connection with the above-entitled case to the following address:

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Please change the delivery mode of correspondence from ELECTRONIC to MAIL.

Docket No. 421/170/8/2 CIP

DEPOSIT ACCOUNT

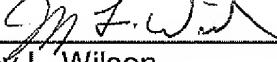
Although it is believed that no fee is due, The Commissioner is authorized to charge any deficiencies of payment associated with the filing of this correspondence to Deposit Account No. 50-0426 to avoid the unintentional abandonment of the instant application.

Respectfully Submitted,

JENKINS, WILSON & TAYLOR, P.A.

Date: February 1, 2008

By:

  
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